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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/665,889	09/19/2003	Daniel J. Gregoire	HRL025-DIV	6992
28848 TOPE-MCK A	7590 08/10/2007 Y & ASSOCIATES	EXAMINER		
23852 PACIFIC COAST HIGHWAY #311			BUEKER, RICHARD R	
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Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

		Application No.	Applicant(s)
Office Action Summary		10/665,889	GREGOIRE ET AL.
		Examiner	Art Unit
		Richard Bueker	1763
Period fo	The MAILING DATE of this communication ap or Reply	pears on the cover sheet with	he correspondence address
A SHO WHIC - Exter after - If NO - Failui Any r	ORTENED STATUTORY PERIOD FOR REPLEMENTED IS LONGER, FROM THE MAILING DISTRICT IN THE MAILING DISTRICT DISTRI	ATE OF THIS COMMUNICA 136(a). In no event, however, may a reply will apply and will expire SIX (6) MONTHS e, cause the application to become ABANI	TION. be timely filed from the mailing date of this communication. DONED (35 U.S.C. § 133).
Status			
2a) <u>□</u> 3) <u>□</u>	Responsive to communication(s) filed on 11 A This action is FINAL . 2b) This Since this application is in condition for alloward closed in accordance with the practice under the	s action is non-final. ince except for formal matters	·
Dispositi	on of Claims		
5)□ 6)⊠ 7)□	Claim(s) 1-14 is/are pending in the application 4a) Of the above claim(s) is/are withdra Claim(s) is/are allowed. Claim(s) 1-14 is/are rejected. Claim(s) is/are objected to. Claim(s) are subject to restriction and/or	wn from consideration.	
Applicati	on Papers		·
10)	The specification is objected to by the Examine The drawing(s) filed on is/are: a) accomplicant may not request that any objection to the Replacement drawing sheet(s) including the correct The oath or declaration is objected to by the Example 1.	cepted or b) objected to by drawing(s) be held in abeyance tion is required if the drawing(s)	See 37 CFR 1.85(a). is objected to. See 37 CFR 1.121(d).
Priority u	inder 35 U.S.C. § 119		
a)[Acknowledgment is made of a claim for foreign All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Bureatee the attached detailed Office action for a list	ts have been received. ts have been received in Appl rity documents have been red u (PCT Rule 17.2(a)).	ication No ceived in this National Stage
Attachment	c(s)		
2) 🔲 Notice 3) 🔲 Inform	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO/SB/08) ' No(s)/Mail Date	Paper No(s)/M	mary (PTO-413) ail Date mal Patent Application

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The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claims 1, 2, 4-8 and 11-14 are rejected under 35 U.S.C. 103(a) as being unpatentable over Leung I (5,198,677) taken in view of Kaufman (4,481,062) and Leung II (5,587,226) and taken in further view of Collins (6,545,420) or Brailove (6,016,036). Leung I (5,198,677) discloses an ion source (Fig. 1) including a plasma generating chamber, magnets arranged around the chamber, a tungsten filament that is heated by a filament power source, a gas port, a bias DC power source, and an array of magnets at the exit of the chamber that act as a magnetic filter of the type claimed by applicants. Leung I teaches that his magnetic filter design desirably produces a stream of mainly atomic ions. Leung's ion source also includes a cooling channel formed between a plasma generation chamber and a cylindrical wall for cooling magnets in the channel; and a liner made of a high-temperature resistant material such as molybdenum provided within the chamber (column 3, line 10 through column 4, line 10). Leung I uses a DC power source 58 to heat the tungsten filament and does not discuss the use of an AC power source to heat his tungsten filament. Also, Leung I does not discuss using his ion source to generate atomic oxygen ions. Kaufman (see Fig. 1 and col. 5, lines 1-6) teaches that either an AC or DC power source can be used to heat a tungsten filament to thermionic temperatures. It would have been prima facie obvious to one skilled in the art to modify the ion source of Leung I (5,198,677) by substituting an AC

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power source for Leung's DC power source 58, because Kaufman teaches that an AC power source was known to be a functional equivalent power source for heating a tungsten filament to thermionic temperatures. Regarding the production of atomic oxygen ions, Leung II (5,587,226) teaches (see the entire patent and in particular col. 13, lines 7-29 and col. 15, lines 13-41) that it is desirable to produce a stream of atomic oxygen ions for materials processing, and Leung II (5,587,226) also teaches that a magnetic filter of the type used by Leung I will produce such a stream of atomic oxygen ions. Therefore, it would have been obvious to one skilled in the art to use the atomic ion source of Leung I (5,198,677) to produce the desired atomic oxygen ions by providing the Lueng I ion source with a source of oxygen as presently claimed. Leung II also teaches (see col. 15, lines 15-41) that his antenna ion source is more desirable for oxygen ion production than a DC discharge ion source of the type disclosed by Leung I. It is noted, however, that a non-preferred embodiment disclosed in the prior art can properly be used as a prior art teaching. The use of a non-preferred embodiment would have been obvious to one willing to accept the drawbacks taught. See In re Boe, 148 USPQ 507; In re Mills, 176 USPQ 196 and In re Susi 169 USPQ 423.

Regarding the newly added limitation to claims 1 and 7 of "a positioning device for allowing a user to position at least one diamond sample in the path of the oxygen plasma exiting through the plasma source exit", Collins (see Fig. 3, for example) and Brailove (see Figs. 1 and 5, for example) have been added to the rejection to show that a plasma treating apparatus having a plasma source for treating a work-piece sample requires a positioning device for allowing a user to position the sample in the path of the

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plasma that exits the plasma source. It would have been obvious to one skilled in the art to provide a sample holder for the plasma treating apparatus of Leung I, in the manner illustrated by Collins or Brailove because a sample positioning device is required to successfully treat a work-piece as desired by Leung I.

Claims 3 and 9 are rejected under 35 U.S.C. 103(a) as being unpatentable over Leung I (5,198,677) taken in view of Kaufman (4,481,062) and Leung II (5,587,226) for the reasons stated in the rejection of claim 1 above, and taken in further view of Anderson (US Patent No. 5,365,070). Anderson teaches an ion source 10 (Fig. 1) including a magnetic holding metal member 12 made of carbon steel which has high magnetic permeability so that magnetic field can easily penetrate there through (column 5, line 47 through column 6, line 2). Therefore, it would have been obvious to one of ordinary skill in the art at the time of the invention to utilize carbon steel in the construction of chamber having magnets there around so that magnetic field more efficiently penetrate there through.

Claim 10 is rejected under 35 U.S.C. 103(a) as being unpatentable over Leung I (5,198,677) taken in view of Kaufman (4,481,062) and Leung II (5,587,226) for the reasons stated in the rejection of claim 1 above, and taken in further view of Mantei (US Patent No. 4,483,737). Mantei teaches a plasma chamber 10 (Figs. 1, 2) including a filament 21 therein and having a plurality of magnets 14 surrounding the chamber wherein the plasma chamber 10 is made of a nonmagnetic material such as stainless steel (column 4, lines 29-56). Therefore, it would have been obvious to one of ordinary

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skill in the art at the time of the invention to utilize nonmagnetic stainless steel as a suitable material for a plasma chamber such as in Leung I.

The new matter rejection has been removed in view of applicants' amendments and accompanying arguments.

Applicants' arguments with respect to their newly added claim limitations have been considered and addressed by the new grounds of rejection stated above.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Richard Bueker whose telephone number is (571) 272-1431. The examiner can normally be reached on 9 AM - 5:30 PM, Monday-Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Parviz Hassanzadeh can be reached on (571) 272-1435. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

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Richard Bueker
Primary Examiner
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